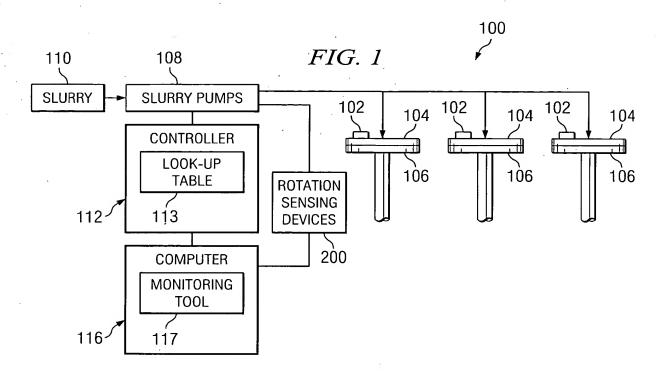
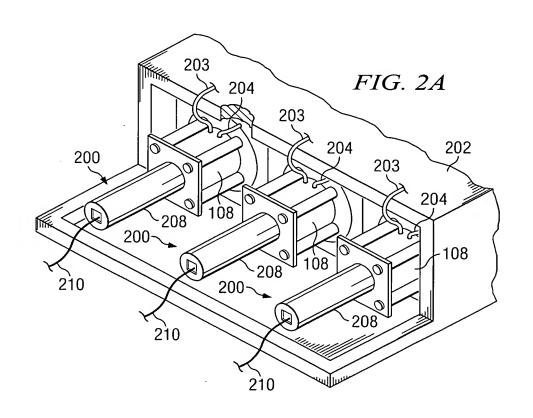
Title: CHEMICAL MECHANICAL POLISHING SLURRY PUMP MONITORING SYSTEM AND METHOD

Inventor: Daniel R. CALDWELL et al.
Filed: November 10, 2003 Serial No: To Be Assigned

Attorney Docket No.: TI-36721 (032350.B574) Sheet 1 of 2

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Title: CHEMICAL MECHANICAL POLISHING SLURRY PUMP MONITORING SYSTEM AND METHOD Inventor: Daniel R. CALDWELL et al. Filed: November 10, 2003 Serial No: To Be Serial No: To Be Assigned Attorney Docket No.: TI-36721 (032350.B574) Sheet 2 of 2 2/2 **START** FIG. 4 400 SEND A DRIVE VOLTAGE FIG. 2B TO A SLURRY PUMP 402 ~ **DELIVER THE SLURRY** TO A POLISHING PAD 206 404 THE SLURRY PUMP

